



INTERNATIONAL GEMOLOGICAL INSTITUTE

ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

LG524212990

IGI LABORATORY GROWN DIAMOND ID REPORT

May 26, 2022

IGI Report Number **LG524212990**

EMERALD CUT

6.07 X 4.48 X 3.02 MM

| | |
|----------------|-----------------------------|
| Carat Weight | 0.80 CARAT |
| Color Grade | H |
| Clarity Grade | SI 1 |
| Polish | VERY GOOD |
| Symmetry | VERY GOOD |
| Fluorescence | NONE |
| Inscription(s) | LABGROWN IGI LG524212990 |

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process and may include post-growth treatment.
Type IIa

LABORATORY GROWN DIAMOND REPORT

IGI LABORATORY GROWN DIAMOND IDENTIFICATION REPORT

May 26, 2022

IGI Report Number **LG524212990**

Description **LABORATORY GROWN DIAMOND**

Shape and Cutting Style **EMERALD CUT**

Measurements **6.07 X 4.48 X 3.02 MM**

GRADING RESULTS

Carat Weight **0.80 CARAT**

Color Grade **H**

Clarity Grade **SI 1**

ADDITIONAL GRADING INFORMATION

Polish **VERY GOOD**

Symmetry **VERY GOOD**

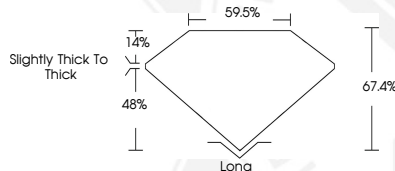
Fluorescence **NONE**

Inscription(s) **LABGROWN IGI LG524212990**

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Type IIa



LASERSCRIBE SM
Sample Images Used



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